

Applicant : Kenichiro Kobayashi et al.  
Appln. No. : 10/737,336  
Page : 2

In the Specification:

Please replace paragraph [0001] with the following amended paragraph.

This application is a continuation of U.S. Patent Application No. 09/838,905 filed on April 20, 2001 entitled METHOD AND APPARATUS TO MEASURE AMOUNT OF MOVEMENT USING GRANULAR SPECK PATTERN GENERATED BY REFLECTING LASER BEAM, now U.S. Patent No. \_\_\_\_\_ U.S. Patent No. 6,847,910.